اثر پاژیخت در محیط آرگون و نیتروژن بر خواص ساختاری، الکتریکی و ابتینیکی لایه‌های رسانای شفاف SnO$_2$:Co به روش اسپری پایروپلاستیز

احمد قلی‌زاده، ناصر تجیر، محمد رضا علی‌نژاد

مشهد، دانشگاه فردوسی مشهد، گروه فیزیک، آزمایشگاه تحکیم‌سازی حالت جامد

Email: ah_gh1359@yahoo.com

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چکیده: در این مقاله، لایه‌های نیمرسان‌های شفاف SnO$_2$:Co اولیه با به روش اسپری پایروپلاستیز تهیه شد و اثر گرمایی در محیط آرگون و نیتروژن بر خواص ساختاری، الکتریکی و ابتینیکی آنها مورد بررسی قرار گرفت. لایه‌های SnO$_2$:Co های با بستر شیشه در دمای ۴۸۰ درجه سانتی‌گراد در آنتونیول شامل کربن اسید کلری و کربن قلع جایگذاری شد. مقدار ناخالصی کلرید کبالت از ۰ تا ۱۴ درصد و زنی در محلول تغییر داده شد. آنالیز طرح‌های برش میانی‌های به شکل Y با ۱۰ درجه درخشانی بین برای انتخاب محتوی ناخالصی کاهش می‌یابد، در حالت که بارامتر ۶ دارای یک کم‌متری در تراکم ۸ درصد و زنی ناخالصی پذیرفته با نسبت اتمی $\frac{[Co]}{[Sn]}$ معادل با ۲۰ درصد امی در محلول است. پاژیخت در محیط آرگون و نیتروژن سبب افزایش مقاومت و پیل الکتریکی، افزایش گراف نواری و شفافیت لایه‌های اولیه با کیفیت می‌شود.

واژه‌های کلیدی: اکسیدهای شفاف، نیمرسان‌های رتقیق، مغناطیسی، اسپری پایروپلاستیز
Influence of N2- and Ar-ambient annealing on the physical properties of SnO2: Co transparent conducting films prepared by spray pyrolysis technique

A. Gholizadeh, N. Tajabor, M. R. Alinejad

Department of Physics, Ferdowsi University of Mashhad, Mashhad, Iran
Email: ah_gh1359@yahoo.com

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Abstract: In this contribution, the Co doped SnO2 transparent semi-conducting films are prepared by spray pyrolysis technique and the influence of N2-and Ar-ambient annealing on their structural, electrical and optical properties are studied. The SnO2:Co thin films were deposited on the glass substrate at substrate temperature of 480 °C using an aqueous-ethanol solution consisting of tin and cobalt chloride. Doping levels of cobalt chloride have been changed from 0 to 14 wt. % in solution. Analysis of the X-ray diffraction patterns show that ‘a’ and ‘V’ parameters of the tetragonal unit cell decrease with increasing impurity content, while c parameter pass through a minimum for an acceptor dopant concentration of 8 wt. % or [Co]/[Sn] atomic ratio equal to 20 atm.% in solution. The N2-and Ar-ambient annealing causes increase of the electrical resistivity, band gap energies, and transparency of the cobalt doped samples.

Keywords: Transparent Conducting Oxides (TCOs); Dilute Magnetic Semiconductors (DMSs); Spray Pyrolysis.

1. Introduction

The TCOs exhibit high optical transparency and good electrical conductivity so that they have received many attentions in both industry and research activities [1, 2]. Nowadays, modern information technology in new nano-electronic and photonic devices utilizes the spin degree of freedom in the magnetic TCOs. Towards this end; one approach is to introduce small amounts of the magnetic dopants (such as Co, Mn, Fe and Ni) into nonmagnetic solids [3-7]. These families of TCOs that are called dilute magnetic semiconductors (DMSs) have been examined for SnO2, In2O3, TiO2 and ZnO transparent thin films [8-12].

SnO2 is a wide-band gap semiconductor with band-gap of $E_g = 3.6 \sim 4.2$ eV. In addition to the excellent optical transparency and high Curie temperature ($T_c$), SnO2 is very stable chemically [1, 13]. It is known that the electrical resistivity of thin films of SnO2 depends on the concentration of oxygen vacancies within their rutile crystal structure (S.G. P4/nmm) [14]. During last decade, many attentions had been paid to tune oxygen vacancies by doping various metallic elements, changing deposition technique and annealing at certain atmospheres [15-19]. Previous results show that substitution of a few percent of Sn$^{4+}$ ions by Co$^{2+}$ not only affects concentration of oxygen vacancies and charge carriers [20], but also introduces cobalt doped SnO2 films which are DMSs with high Curie temperature ($T_c = 650 \, ^\circ$K) and giant magnetic moment per Co- atoms which has not been seen in any DMS system, thus far [21]. So, SnO2: Co films are potentially interesting DMSs for using in new spintronic and magnetooptic devices.

In this work Co-doped SnO2 films with various doping levels have been deposited using spray pyrolysis technique. Then, structural, electrical,
and optical properties of the prepared samples have been studied. In the study of SnO$_2$ crystallites, the (110), (101) and (100) are recognized as three significant crystallographic planes. Previous theoretical and experimental results indicate that the (110) plane has lowest surface energy and so stability [22]. Surface energy, which is the characteristic parameter of the faceting behavior of SnO$_2$ polycrystals, depends on the chemical potential of oxygen and deviation from the surface stoichiometry. Considering that the chemical stoichiometry of planes is affected by the deposition method and post annealing of the deposited films at certain atmospheres, we expect that the faceting behavior of the Co-doped SnO$_2$ samples may be controlled by changing these parameters. Therefore, the effects of N$_2$- and Ar-ambient annealing on the faceting, electrical and optical properties of Co-doped SnO$_2$ films are studied.

2. Experimental

2.1 Material preparation and deposition of films

The undoped SnO$_2$ thin films were deposited using an aqueous-ethanol solution including SnCl$_2$.2H$_2$O, H$_2$O and CH$_3$CH$_2$OH with the same weight percentage (1: 1: 1) and a few ml of hydrochloric acid by the spray pyrolysis technique. Also, Co doped SnO$_2$ films have been prepared using 0, 2, 4, 8, 10, 12, 14 wt. % of CoCl$_2$.6H$_2$O that added to the initial solution without any changes in the clarity of the solution. The spray solution compositions and atomic concentration ratios in the prepared solutions are given in Table 1.

For film deposition, a clean substrate (the glass substrates with 1 mm thickness and 25 × 75 mm dimensions), was placed on the hot plate at temperatures ranging from 480-500°C, which is known to be the optimal range for the formation of SnO$_2$ films [23]. Then solution was sprayed at the following conditions: carrier-gas pressure (O$_2$): 1.7-2 atm., flow rate of solution: 14 ml/min, solution volume: 10 cc and substrate-to-nozzle distance: 45 cm. For preventing reduction at hot plate temperature, spraying was done in short time intervals. All samples were prepared almost with the same conditions. The metallic salt solution, when sprayed onto a hot substrate, pyrolytically decomposes and a chemical reaction takes place on the heated substrate and at least a thin layer of SnO$_2$ (undoped or doped) is deposited. Thin films with about 0.4 µm thickness are prepared in this manner, as estimated by SEM micrographs and optical method. After deposition, the original thin samples were cut into 13 × 26 mm dimensions and four similar series of the Co-doped SnO$_2$ films were prepared for executing post-annealing treatments. Below, we will call each one of these series in the following manner. SnO$_2$: Co transparent conducting films prepared with different Co concentrations: (Series 1) as-deposited and (Series 2) annealed at 550°C in the Ar, and, (Series 3) in the N$_2$ atmospheres for 5h, and, (Series 4) in Ar followed by N$_2$ for 5h, respectively.

Table 1. Composition of the Co-doped SnO$_2$ solutions.

<table>
<thead>
<tr>
<th>CoCl$_2$.6H$_2$O (M)</th>
<th>SnCl$_2$.2H$_2$O (M)</th>
<th>CoCl$_2$.6H$_2$O (M)</th>
<th>[Co] / [Sn] (atm.% in solution)</th>
</tr>
</thead>
<tbody>
<tr>
<td>0</td>
<td>14.6</td>
<td>0</td>
<td>0</td>
</tr>
<tr>
<td>2</td>
<td>14.6</td>
<td>0.73</td>
<td>5</td>
</tr>
<tr>
<td>4</td>
<td>14.6</td>
<td>1.46</td>
<td>10</td>
</tr>
<tr>
<td>8</td>
<td>14.6</td>
<td>2.92</td>
<td>20</td>
</tr>
<tr>
<td>10</td>
<td>14.6</td>
<td>3.65</td>
<td>25</td>
</tr>
<tr>
<td>12</td>
<td>14.6</td>
<td>4.30</td>
<td>30</td>
</tr>
<tr>
<td>14</td>
<td>14.6</td>
<td>5.11</td>
<td>35</td>
</tr>
</tbody>
</table>
2.2 Structural
Microstructure of the samples was analyzed using polarized optical microscope as well as scanning electron microscope. Frequency distribution of the grains size within the samples has been studied using LICA analyzer (QW500 model) based on the optical images. The X-ray diffraction patterns of the prepared thin films were taken by a D8 Advance Bruker system using Cu-Kα radiation. Phase analysis of the samples has been done based on the XRD patterns. The information on microstrain (εs) and the crystallite size (D) of the deposited films have been obtained from the full-width at half-maximum (FWHM) of the diffraction peaks (θ) via Williamson-Hall relation [24]:

\[
\frac{\beta \cos \theta}{\lambda} = \frac{1}{D} + \frac{\varepsilon_s \sin \theta}{\lambda}
\]

And sherrer’s relation:

\[
D = \frac{0.9 \lambda}{\beta \cos \theta}
\]

Lattice parameter refinements are performed using CELREF software from LMGP institute (Grenoble - France).

2.3 Electrical
Electrical measurements consist of the resistivity; carrier concentration and mobility determination have been done via Van der Pauw method [25]. In addition, Seebeck’s effect measurements were performed for distinction of the carrier type.

2.4 Optical
Absorption coefficient is suitable tool for studying band gap energy. Optical transmission and absorption spectra of the Co-doped SnO2 films between 200 and 1000 nm wave lengths have been recorded at room temperature using HP-UV-Vis system (Agilent 8453, model). For estimating band gap, the optical absorption coefficient (α(λ)) was calculated from the absorption spectra (A(λ)) using the following equation [26]:

\[
\alpha(\lambda) = \frac{2.303 \cdot A(\lambda)}{t}
\]

In which, t is thickness of the deposited film. Then, a self consistence role based on the following relation was used for deducing optical band gap energy, Es:

\[
(\alpha \cdot h \cdot v) = B \cdot (h \cdot v - E_g)^r
\]

Where, B is an energy-independent constant and r is a parameter refers to the type of excitation of carriers across the band gap. In fact, r = 0.5, 2, 1.5 and 3 corresponds to the direct, indirect, forbidden direct and forbidden indirect type of transitions, respectively. Details of this method can be found in ref. [27].

For estimating Urbach edge (E0), we refer to the following relation that is valid for direct optical transitions in the spectral range [28],

\[
\alpha(hv) = \alpha_o \exp \left( \frac{hv - E_g}{E_o} \right)
\]

Where, αo is the optical absorption coefficient at the band gap energy edge. The value of E0 can be deduced as inverse of the slope of ln(α) vs. hv plot.

Thickness of the deposited films has been estimated using following formula:

\[
t = \frac{1}{2 (\frac{1}{\lambda_1} - \frac{1}{\lambda_2}) n_o}
\]

In which, λ1 and λ2 are wavelengths of two consecutive maximums in the transmission spectra. Also, n_o is the refraction index of the films which has been selected equal to 2 based on the reported values for the mean value of the refraction index of TCOs [29].

3. Results and discussion
Typical optical micrographs of the samples are shown in Fig. 1. These micrographs consist of a uniform bright background and a mixture of dark and white regions (grains). Similarly, SEM micrographs confirm same microstructure (Fig. 2a). Local EDX compositional analysis shows that these dark grains mainly contain O, Sn and Co atoms, while the white grains only consist of O and Sn atoms (Fig. 2b and c). As shown in Fig. 1, one may find very small ~1 to 25 μm size of dark grains in all four images, except in Fig. 1a.

The XRD patterns of the samples are shown in Fig. 3. It is clear that as-deposited layers are fine polycrystalline and some Co-doped films are self-orientated. Comparison of the sharpness of diffraction peaks of the undoped films indicate that the size of crystallites considerably increases by annealing at N2-ambient, while Ar-ambient has not such an effect. The preferential orientation and faceting behaviors can be observed in Fig. 4, where the normalized intensity of the (110), (101), (200) and (211) Bragg’s peaks are plotted as a function of cobalt content for the series 1 samples.
Comparative analysis of the XRD patterns indicates that the faceting characteristics are conserved after post annealing treatments. It is clear that the ratio of the intensity of (200) diffraction peaks considerably increases with increasing concentration of Co impurities to 25 atm.%. Analyses of these results show the faceting of films along tetragonal a-axis, especially for the samples with 20 and 25 atm.% impurity level. The preferential alignment usually originates from the created strains during deposition of films that are a function of deposition parameters such as substrate temperature and deposition rate [30]. Here, the observed faceting can be attributed to the decrease of the surface energy density of the (200) plane with respect to that of (110) after partial substitution of Sn by Co [22].

Fig. 1. Polarized optical micrographs of Co-doped SnO₂ thin films: (a) 0; (b) 10; (c) 20; and (d) 30 atm.%.

Fig. 2. (a) A typical SEM micrograph of the 20 atm.% Co-content in solution. (b) And (c) Local EDX analysis of the elemental composition of the white and dark grains, respectively.
Fig. 3. XRD patterns of SnO$_2$:Co transparent conducting films prepared with different Co concentration: (a) as-deposited, (b) annealed at 550°C in Ar, (c) in N$_2$ atmospheres for 5h, and, (d) in Ar followed by N$_2$ for 5h. The XRD pattern of Co$_3$O$_4$ is given on the top of figure, too.
As shown in Fig. 3, some additional peaks appear in the XRD pattern of series 1 sample with more than 20 atm.% doping level. These additional peaks correspond to the standard diffraction pattern of Co$_2$SnO$_4$ and Co$_3$O$_4$ phases with cubic structure. The presence of such phases also reported in Zn$_{1-x}$Co$_x$O samples [31] and Sn$_{1-x}$Co$_x$O$_2$ [32] samples, which may affect structural, electrical and optical properties of the studied samples. The unwanted phases considerably decrease after annealing and all the annealed samples seem to be single phase. The derived rutile lattice parameters of the series 1 samples are given in Fig. 5. This figure shows that ‘a’ and ‘V’ (Volume of unit cell) parameters of the tetragonal unit cell decrease with increasing cobalt content, while ‘c’ parameter passes through a minimum for 20 atm % doping level. Calculated lattice parameters of the annealed samples exhibit similar behavior, too. It is well known that the ionic radius of Co$^{3+}$ (0.63 Å) is less, while the ionic radius of Co$^{2+}$ (0.72 Å) is greater than that of Sn$^{4+}$ (0.71 Å) [33]. Therefore, decrease of ‘a’ and ‘V’ is natural consequence of the substitution of Co$^{3+}$ ions instead of Sn$^{4+}$ in the SnO$_2$ rutile structure.

In addition, observed enhancements of the full width at half the maximum (FWHM) of the XRD peaks by increasing Co-content, indicating possible changes in the crystallite size and microstrains. The crystallite sizes and microstrains have been calculated based on the (110), (200) and (101) Bragg’s peaks in the XRD patterns (Fig. 6). These results show that the size of crystallites decreases with increasing microstrain (and conversely), and both of them become extremum about 20 atm.% doping level. In fact, minimum of the ‘c’ parameter is accompanied by the minimum size of crystallites and the maximum value of microstrains. So, one may attribute the abnormal minimum of the ‘c’ lattice parameter to the increase of the introduced stress after substitution of Sn by Co in the rutile structure. Also, decrease of the microstrains for more than 20 atm.% doping level is compensated by the formation of Co$_2$SnO$_4$ and Co$_3$O$_4$ unwanted phases in the series 1 samples.

Results of the electrical measurements exhibit gradual increase of the resistivity with cobalt additives (Table 2). Also, the carrier concentration decreases by increasing Co content to 10 atm.%, and then, approximately remains constant for additional doping level. Decrease of the n-type carrier concentration can be attributed to the substitution of Sn$^{4+}$ by smaller Co$^{3+}$ in the rutile unit cell. Although, by this trend one may expect that the type of carriers should gradually changes from n$^-$ to p$^+$ with increasing doping level, but results of the Seebeck’s measurements emphasize on the n-type carriers in all studied samples. This can be explained considering that the XRD patterns show the complete penetration of Co atoms within crystal structure of SnO$_2$ only for
lower than 25 atm.% doping levels. Variation of the mobility in terms of carrier concentration is due to a combination of ionized impurity and grain boundary scattering mechanisms where the former seems to be dominated.

Fig. 5. Variation of the crystal lattice parameters of the series 1 samples vs. Co/Sn atomic ratio.

Fig. 6. Crystallite sizes and microstrains calculated based on the (110), (200) and (101) Brag’s peaks in the XRD patterns of the series 1 samples vs. Co/Sn atomic ratio.

Table 2. Resistivity ($\rho$), carrier concentration ($n$) and Seebeck’s coefficient ($\alpha$) of the series 1 samples.

<table>
<thead>
<tr>
<th>Sample (atm.%)</th>
<th>Thickness (nm)</th>
<th>$\rho$ (Ω cm)</th>
<th>$n \times 10^{16}$ (cm$^{-3}$)</th>
<th>$\alpha$ (µV/K)</th>
</tr>
</thead>
<tbody>
<tr>
<td>0</td>
<td>~400</td>
<td>0.025</td>
<td>-766.00</td>
<td>-140</td>
</tr>
<tr>
<td>5</td>
<td>~400</td>
<td>2.32</td>
<td>-1.27</td>
<td>-75</td>
</tr>
<tr>
<td>10</td>
<td>~400</td>
<td>4.23</td>
<td>-0.77</td>
<td>-60</td>
</tr>
<tr>
<td>20</td>
<td>~400</td>
<td>2.92</td>
<td>-0.89</td>
<td>-40</td>
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<td>25</td>
<td>~400</td>
<td>16.50</td>
<td>-0.69</td>
<td>-50</td>
</tr>
<tr>
<td>30</td>
<td>~400</td>
<td>25.00</td>
<td>-0.67</td>
<td>-55</td>
</tr>
<tr>
<td>35</td>
<td>~400</td>
<td>28.10</td>
<td>-0.64</td>
<td>-65</td>
</tr>
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Results of the electrical measurements after annealing are shown in Fig. 7. It is clear that the annealing cause increase of the electrical resistivity of the cobalt doped samples and this increase is mostly a function of the annealing duration. In addition, comparison of the effect of N2-ambient and Ar-ambient annealing on the resistivity indicates that about 40% of this increase should be due to penetration of the nitrogen ions within the rutile structure. The structural and compositional relaxations should be origin of the remained 60% of the increase of resistivity.

Optical spectra show that transparency of the samples in the visible region decreases between 10 and 40% by increasing Co-content (Figs. 8, 9). This was expected because of increase of the average size of dark grains of Co content as depicted in fig. 3. Films thickness was estimated 400 nm by using eq. (6). However, transparency of the samples with lower that 30 atm.% doping levels are slightly increased after post annealing treatments. The observed increase may be ascribed to the decrease of the surface defects due to post annealing treatments [35].

Corresponding best-fitted values of the band gap energy that are deduced via the self-consistence rate of eq. (4) are given in Table 3, where the value of r is consistently supposed to be 0.5 for all samples which indicate mechanism of the excitations is based on the direct transitions in all samples. Also, for showing relationship of the band gap energy variations and the Urbach energy, these two quantities are drawn versus Co-doping level in Fig. 10. Analogous variations of the Urbach and the band gap energies in this figure indicate that the observed changes in the band gap can be due to the effect of Co on the crystalline perfection of SnO2.

The derived bang gap energies are shown in Fig. 11, which in all samples become minimized at about 10 atm.% doping level. However, these are some increase in them by post annealing treatment.

4. Conclusions
The Co doped SnO2 TCOs are prepared by spray pyrolysis technique and the influence of N2 and Ar-ambient annealing on their structural, electrical and optical properties were studied. The XRD patterns show that some of the Co-doped films exhibit a faceting characteristic that is conserved after post annealing treatments. This faceting is attributed to the decrease of the surface energy density of the (200) plane respect to that of (110) after substitution of Sn by Co.

Analyses of the XRD patterns show that the size of crystallite decreases with increasing microstrain and both of them become extremum at about 20 atm.% doping level. In addition, ‘a’ and ‘V’ parameters of the tetragonal unit cell decrease with increasing impurity content, while c parameter pass through a minimum at 20 atm.% impurity level.

![Image](image_url)

**Fig. 7.** Electrical resistivity of SnO2:Co transparent conducting films prepared with different Co concentration (a) as-deposited, (b) annealed at 550°C in Ar, (c) in N2 atmospheres for 5h, and, (d) in Ar followed by N2 for 5h.
Fig. 8. Typical (a) absorbance and (b) transparency spectra of the series 1 samples vs. wavelength for 0, 5, 20, and 35% of Co/Sn atomic ratio. In the inset of fig.(a), $(\alpha h v)^2$ vs. $h v$ for 10% of Co/Sn atomic ratio, from which the optical band gap value is deduced. In the inset of fig.(b), variation of the transmittance of SnO$_2$: Co transparent conducting films at typical 600 nm wavelength.

Fig. 9. The optical transmittance of SnO$_2$: Co transparent conducting films prepared with different Co concentration: (a) as-deposited, (b) annealed at 550°C in Ar, (c) in N$_2$ atmospheres for 5h, and, (d) in Ar followed by N$_2$ for 5h.
Table 3. Band gap energy, Urbach energy and B constant (as defined in eq. 4) of the series 1 samples.

<table>
<thead>
<tr>
<th>Sample (atm.%)</th>
<th>$E_g$ (eV)</th>
<th>$E_0$ (meV)</th>
<th>B (cm$^{-2}$eV$^{1/2}$)</th>
</tr>
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<tbody>
<tr>
<td>0</td>
<td>4.053</td>
<td>387</td>
<td>741015</td>
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<td>5</td>
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<tr>
<td>35</td>
<td>4.010</td>
<td>390</td>
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Fig. 10. Variations of the Urbach ($E_0$) and the band gap energy ($E_g$) of the series 1 samples vs. Co/Sn atomic ratio.

Fig. 11. Variations of the band gap energy of SnO$_2$: Co transparent conducting films prepared with different Co concentration (a) as-deposited, (b) annealed at 550°C in Ar, (c) in N$_2$ atmospheres for 5h, and, (d) in Ar followed by N$_2$ for 5h.

Electrical measurements demonstrate gradual increase of the resistivity by increasing doping level. The annealing causes increase of the electrical resistivity of the cobalt doped samples and this increase is mostly a function of the annealing duration. About 40% of this increase should be due to penetration of the nitrogen ions within the rutile structure and the remained 60% may be attributed to the structural and compositional relaxations.

The optical spectra show that the transparency of the samples in the visible region decreases between 10 and 40% by increasing cobalt content. However, the transparency of the samples with
lowers than 30 atm.% doping level slightly increases after post annealing treatments.

The bang gap energies become minimized at about 10 atm.% doping level while these are some increase by post annealing treatment. In addition, the mechanism of excitations is based on the direct transitions in all samples. The observed band gap variations may attribute to the defect concentration and crystalline perfection.

References